Contact-G

AFM Tip

| SHAPE | HEIGHT | SETBACK | RADIUS | HALF CONE ANGLE |
|---------|------------------------|------------------------|--------|--|
| Rotated | 17 μm (15 – 19 μm)* | 15 μm (10 – 20 μm)* | 10 nm | $20^{\circ}25^{\circ}$ along cantilever axis, $25^{\circ}30^{\circ}$ from side, 10° at the apex |

AFM Cantilever

| Cantilever A | | |
|---------------------|---------------------------|--|
| Shape | Beam | |
| Force Constant | 0.2 N/m (0.07 – 0.4 N/m)* | |
| Resonance Frequency | 13 kHz (9 – 17 kHz)* | |
| Length | 450 μm (440 – 460 μm)* | |
| Width | 50 μm (45 – 55 μm)* | |
| Thickness | 2 μm (1 – 3 μm)* | |

^{*} typical range

Coating

Uncoated

Alignment Grooves

This product features alignment grooves on the back side of the holder chip.

Additional Info

Monolithic silicon AFM probe for contact mode and lateral force mode operation.

The rotated AFM tip allows for more symmetric representation of high sample features. The consistent AFM tip radius ensures good resolution and reproducibility.

The AFM holder chip fits most commercial AFM systems as it is industry standard size.